

Electronic Patent Application Fee Transmittal

Application Number:	10511607			
Filing Date:	04-Nov-2004			
Title of Invention:	METHOD AND DEVICE FOR CLEANING RAW MATERIAL GAS INTRODUCTION TUBE USED IN CVD FILM FORMING APPARATUS			
First Named Inventor/Applicant Name:	Kenichi Hama			
Filer:	Marvin Jay Spivak/sinee samla			
Attorney Docket Number:	260615US2XPCT			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1400	1400
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				1700